

SCOPE OF ACCREDITATION

Chemical Processing

Fort Walton Machining Inc 635 Anchor Street Fort Walton Beach, FL 32548

This certificate expiration is updated based on periodic audits. The current expiration date and scope of accreditation are listed at: www.eAuditNet.com - Online QML (Qualified Manufacturer Listing).

In recognition of the successful completion of the PRI evaluation process, accreditation is granted to this facility to perform the following:

AC7108 Rev G - Nadcap Audit Criteria for Chemical Processing ANODIZING (NOT FOR METAL BOND) Anodize Aluminum, Chromic Acid Other Anodize Aluminum Chromic Acid Anodize Aluminum, Hard Anodize Other Anodize Aluminum Hard Anodize Anodize Aluminum, Sulfuric Acid Other Anodize Aluminum Sulfuric Acid Dye Seal CONVERSION COATING Aluminum Other Aluminum ETCH AS A PREPARATION FOR NDT (AC7108/2 MUST ALSO BE SELECTED) Ovens Used at a Set Point Above 250°F Ovens Used at a Set Point of 250°F or Below PAINT/DRY FILM (AC7108/1 MUST ALSO BE SELECTED) PASSIVATION Other Passivation Solution Analysis In Support of AC7108 Stripping of Coatings **Inorganic Coatings** Other Stripping **Organic Coatings** Testing Performed Internally In Support of the Chemical Process Accreditation

- B03 Metallographic Preparation In Support of AC7108
- B05 Salt Spray Testing In Support of AC7108
- B06 Water Immersion / Humidity Testing In Support of AC7108
- B09 Taber Wear Testing In Support of AC7108
- B10 Adhesion Testing (Adhesion Tape Testing) In Support of AC7108
- B12 Adhesion Testing (Bend Test) In Support of AC7108
- B13 Coating Weight Testing In Support of AC7108
- B14 Conductivity Testing In Support of AC7108
- B16 Coating Thickness Measurement In Support of AC7108
- B21 Other Testing In Support of AC7108

AC7108/1 Rev B - Nadcap Audit Criteria for Painting & Dry Film Coatings

Painting

Other

AC7108/2 Rev D - Nadcap Audit Criteria for Etch Processes (Blue Etch Anodize, Local, Macrostructure, Nital/Temper, Pre-Penetrant)

Pre-Penetrant Etch

Solution Analysis Performed On Site in Support of Etch Processes